



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **OZAKI, Takashi, et al.**

Group Art Unit: **2813**

Serial No.: **10/517,765**

Examiner: **MCCALL SHEPARD, Sony**

Filed: **February 3, 2006**

P.T.O. Confirmation No.: **6791**

FOR: **SUBSTRATE TREATING APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 30, 2008

Sir:

In response to the Office Action dated **February 5, 2008**, extended from **May 5, 2008** to **August 5, 2008** by a **three (3)** month Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.